Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	((mask same (layout same design)) and (performance adj variation) and (((crititcal adj dimension) adj variation) same (edge adj (placement adj error)) same tolerance) and features)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:33
L2	0	((mask same (layout same design)) and (performance adj variation) and (((critical adj dimension) adj variation) same (edge adj (placement adj error)) same tolerance) and features)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:34
L3	1	((mask same (layout same design)) and (performance adj variation) and (((critical adj dimension) same variation) same (edge adj (placement adj error)) same tolerance) and features)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:35
L4	. 1	(((mask same (layout same design)) and (performance adj variation) and (((critical adj dimension) same variation) same (edge adj (placement adj error)) same tolerance) and features)). CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:37
L5	0	((mask same (layout same design)) and (performance adj variation) and (((critical adj dimension) same variation) same (overlay adj error) same tolerance) and features)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:37
L6	1	(((mask and (layout and design)) and (performance and variation) and (((critical and dimension) same variation) and (edge and (placement and error)) and tolerance) and features)).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:38
S1	781	716/21	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:00
. 52	1089	716/19	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:41

S3	0	(716/21).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correctiom same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:55
S4	0	(716/19).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correctiom same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:53
S5	0	("716"/\$).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correctiom same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:53
S6	0	(mask same (design adj layout)) and (yield) and (minimum same correctiom same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:53
S7	0	(mask same (design same layout)) and (yield) and (minimum same correctiom same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:55
S8	38	(mask same (design same layout)) and (yield) and (correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:00
S9	0	(716/21).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:56
S10	1	(716/19).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:56
S11	1	("716"/\$).ccls. and (mask same (design adj layout)) and (yield) and (minimum same correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:57
S12	2	(mask same (design adj layout)) and (yield) and (minimum same correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:57

	,			T		
S13	3	(mask same (design same layout)) and (yield) and (minimum same correction same cost)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:01
S14	0	(mask same (design same layout)) and (yield) and (minimum adj (correction adj cost))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:01
S15	2	(mask same (design same layout)) and (yield) and (minimum same (correction adj cost))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:30
S16	1	(mask same (design same layout)) and (yield) and (minimum same (correction adj cost)) and (probability adj (density adj function)) and (correction adj algorithm) and (signal adj (arrival adj time))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:13
S17	1	((mask same (design same layout)) and (yield) and (minimum same (correction adj cost)) and (probability adj (density adj function)) and (correction adj algorithm) and (signal adj (arrival adj time))).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:12
S18	0	(mask same (design same layout)) and (torleab\$6 or accept\$7) and (performance adj variation) and ((critical adj dimension) adj variation) and (edge adj (placement adj error))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:25
S19	0	(mask same (design same layout)) and (tolerab\$6 or accept\$7) and (performance adj variation) and ((critical adj dimension) adj variation) and (edge adj (placement adj error))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:27
S20	1	(mask same (design same layout)) and (tolerable or acceptable) and (performance adj variation) and ((critical adj dimension) same variation) and tolerance and (edge adj (placement adj error))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:28
S21	1	(mask same (design same layout)) and (yield) and (minimum same (correction same cost)) and mapping and (resolution adj enhancement)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 17:32

S22	1	((mask same (layout same delay)) same (correction or modification)) and (cost and yield)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:03
S23	21077	(((mask same (layout same delay)) same (correction or modification) sam algorithm) and (cost and yield))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:04
S24	1	(((mask same (layout same delay)) same (correction or modification) same algorithm) and (cost and yield))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:04
S25	0	(((mask same (layout same delay)) same (correction or modification) same algorithm) and (cost and yield)).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:05
S26	4	(((mask same (layout same design)) same (correction or modification) same algorithm) and (cost and yield))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:08
S27	1	(((mask same (layout same design)) same (correction or modification) same algorithm) and (cost and yield)).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:17
S28	1	(((mask same (layout same design)) same (probability adj (density adj function)) same (arrival adj time)) and (algorithm) and (cost and yield))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:19
S29	1	(((mask same (layout same design)) same (probability adj (density adj function)) same (arrival adj time)) and (algorithm) and (cost and yield)).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:23
S30	1	(((mask and (layout and design)) and (probability and (density and function)) and (arrival and time)) and (algorithm) and (cost and yield)).CLM.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/27 11:22



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask layout) <and> (correction algorithm))<in>metadata)"

Your search matched 0 documents.

⊠e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask layout) <and> (correction algorithm))<in>metadata)

>>

Check to search only within this results set

» Key

IEEE Journal or

Magazine

IEEE JNL IEE JNL

IEE Journal or Magazine

IEEE CNF

IEEE Conference

Proceeding

IEE CNF IEE Conference

Proceeding

IEEE STD IEEE Standard

Citation C Citation & Abstract

No results were found.

Display Format:

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

Help Contact Us Privacy &:

Indexed by #Inspec © Copyright 2005 IEEE -



Welcome United States Patent and Trademark Office

□ Search Results

BROWSE

Check to search only within this results set

Display Format: © Citation © Citation & Abstract

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask layout) <and> (correction) <and> (yield) <and> (cost))<in>metadata)" Your search matched 0 documents.

⊠e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

New Search

Modify Search

(((mask layout) <and> (correction) <and> (yield) <and> (cost))<in>metadata)

>>

» Key

IEEE Journal or

Magazine

IEE JNL

IEE Journal or Magazine

IEEE CNF

IEE CNF

· IEEE JNL

IEEE Conference

Proceeding

IEE Conference

Proceeding

No results were found.

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

search.

IEEE STD IEEE Standard

Help Contact Us Privacy &:

© Copyright 2005 IEEE -

indexed by **AInspec**



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask layout) <and> (modification) <and> (yield) <and> (cost))<in>metadata..." Your search matched 0 documents.

☑ e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask layout) <and> (modification) <and> (yield) <and> (cost))<in>metadata)

>>

Check to search only within this results set

» Key

IEEE Journal or

IEEE JNL

Magazine

IEE JNL

IEE CNF

IEE Journal or Magazine

IEEE CNF

IEEE Conference

Proceeding

IEE Conference Proceeding

No results were found.

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

search

IEEE STD IEEE Standard

Help Contact Us Privacy &:

© Copyright 2005 IEEE -

indexed by #Inspec

***:



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask layout) <and> (correction cost) <and> (yield))<in>metadata)" Your search matched 0 documents.

⊠e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask layout) <and> (correction cost) <and> (yield))<in>metadata)

>>

Check to search only within this results set

» Key

Display Format:

Citation C Citation & Abstract

IEEE JNL

IEEE Journal or

Magazine

IEE JNL

IEE Journal or Magazine

IEEE CNF IEEE Conference No results were found.

Proceeding **IEE CNF**

IEE Conference

Proceeding

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

. . .

IEEE STD IEEE Standard

Help Contact Us Privacy &:

© Copyright 2005 IEEE -

indexed by #Inspec



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask design layout) <and> (correction cost) <and> (yield))<in>metadata)"

⊠e-mail

Your search matched 0 documents.

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask design layout) <and> (correction cost) <and> (yield))<in>metadata)

Σ

Check to search only within this results set

» Key

Display Format: © Citation C Citation & Abstract

IEEE JNL

IEEE Journal or

Magazine

IEE JNL

IEE Journal or Magazine

IEEE CNF

IEE CNF

IEEE Conference

Proceeding

IEE Conference

Proceeding

No results were found.

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

....

IEEE STD IEEE Standard

Help

Contact Us Privacy &:

Indexed by #Inspec

© Copyright 2005 IEEE -



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask design layout) <and> (probability density function) <and> (yield))<in>meta..." Your search matched 0 documents.

⊠e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask design layout) <and> (probability density function) <and> (yield))<in>metadat

Check to search only within this results set

» Key

IEEE JNL

IEEE Journal or

Magazine

IEE JNL

IEE Journal or Magazine

IEEE CNF

IEEE Conference

Proceeding

No results were found.

IEE Conference IEE CNF Proceeding

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

IEEE STD IEEE Standard

indexed by #Inspec Contact Us Privacy &: © Copyright 2005 IEEE -



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask design layout) <and> (performance variation) <and> (tolerance))<in>metadat..." Your search matched 0 documents.

⊠ e-mail

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask design layout) <and> (performance variation) <and> (tolerance))<in>metadat >>>

© Citation C Citation & Abstract

Check to search only within this results set

» Key

IEEE Journal or

Magazine

IEE JNL

IEEE JNL

IEE Journal or Magazine

IEEE CNF

IEE CNF

IEEE Conference

Proceeding

IEE Conference

Proceeding

No results were found.

Display Format:

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

search.

IEEE STD IEEE Standard

Help Contact Us Privacy &:

© Copyright 2005 IEEE -

Indexed by #Inspec

.....



Welcome United States Patent and Trademark Office

☐ Search Results

BROWSE

SEARCH

IEEE XPLORE GUIDE

Results for "(((mask) <and> (design layout) <and> (performance variation) <and> (tolerance))<..." Your search matched 0 documents.

A maximum of 100 results are displayed, 25 to a page, sorted by Relevance in Descending order.

» Search Options

View Session History

Modify Search

New Search

(((mask) <and> (design layout) <and> (performance variation) <and> (tolerance))<in>

Check to search only within this results set

» Key

Display Format: © Citation C Citation & Abstract

IEEE JNL

IEEE Journal or

Magazine

IEE JNL

IEE Journal or Magazine

IEEE CNF

IEE CNF

IEEE Conference

Proceeding

IEE Conference Proceeding

No results were found.

Please edit your search criteria and try again. Refer to the Help pages if you need assistan

IEEE STD IEEE Standard

Help Contact Us Privacy &:

© Copyright 2005 IEEE -

indexed by #Inspec